



1204.41259X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. UCHIDA, et al.
Serial No. 10/069,404
Filed: MAY 6, 2002
For: POLISHING MEDIUM FOR CHEMICAL-MECHANICAL
POLISHING, AND POLISHING METHOD
Group AU: 1765
Examiner: Lynette T. Umez Eronini
Confirm. No: 3597

AMENDMENT

Mail Stop: AMEND – FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 12, 2006

Sir:

In response to the Office Action mailed July 12, 2005, the period for response having been extended for three (3) months by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.

01/13/2006 HALI11 00000032 10069404

02 FC:1202 150.00 OP
03 FC:1201 200.00 OP